

FURTHER ANALYTICAL METHODS

- **TOPOGRAPHY**
 - SPM
 - CLSM (confocal laser scanning microscope)
- **INTERNAL STRUCTURE**
 - X-ray microscope
 - scanning acoustic microscope

1

SPM – SCANNING PROBE MICROSCOPY

Advantages

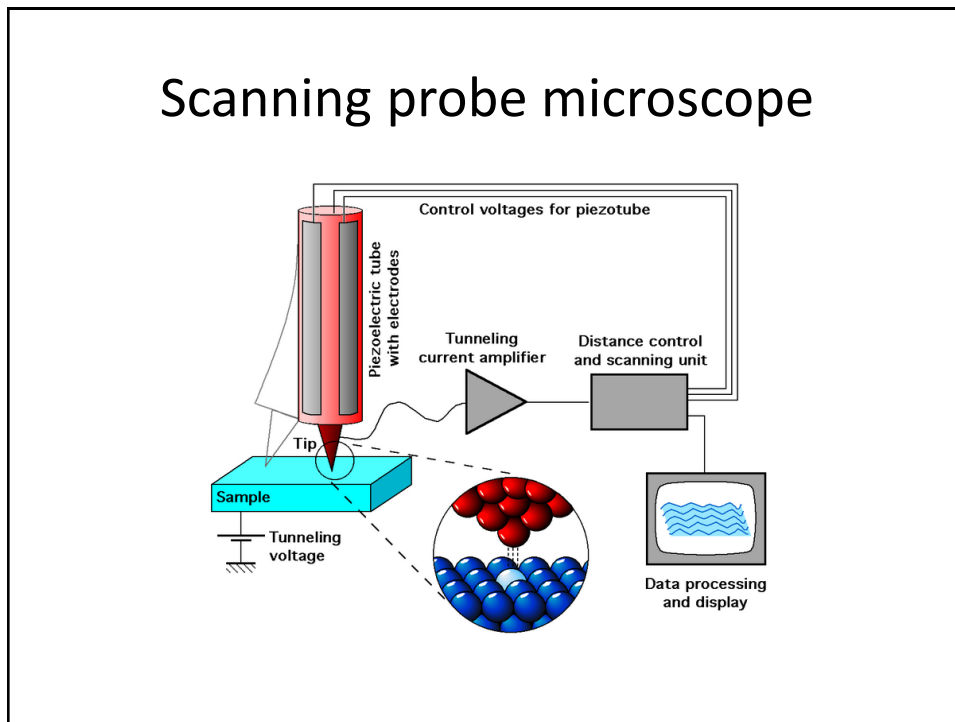
- atomic resolution
- no difficult sample preparation

Disadvantages

- max. 10 μm^2 area
- max. some μm vertical resolution
- vibration sensitivity

2

Scanning probe microscope



3

HISTORY OF SPM METHODS NOBEL PRIZES

STM (Scanning Tunneling Microscope)

1981: Gerd Binnig, Heinrich Rohrer (IBM, Zürich);

Nobel: 1986

(shared with Ernst Ruska, inventor of TEM)

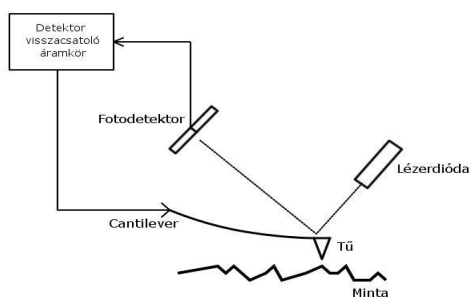
AFM (Atomic Force Microscope)

1986: Binnig, Rohrer, Quate (IBM, Zürich és Stanford University)

4

AFM – ATOMIC FORCE MICROSCOPE

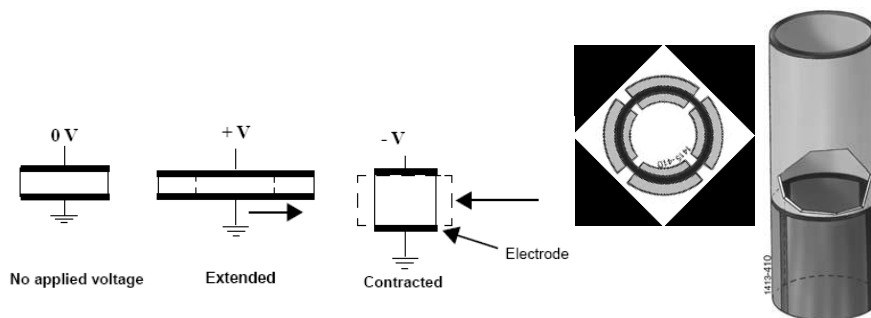
A very sharp needle is moving over the sample surface. The vertical position of the needle is determined by the attractive and repulsive forces between the needle and the atoms of the surface. The needle is fixed on an elastic cantilever.



5

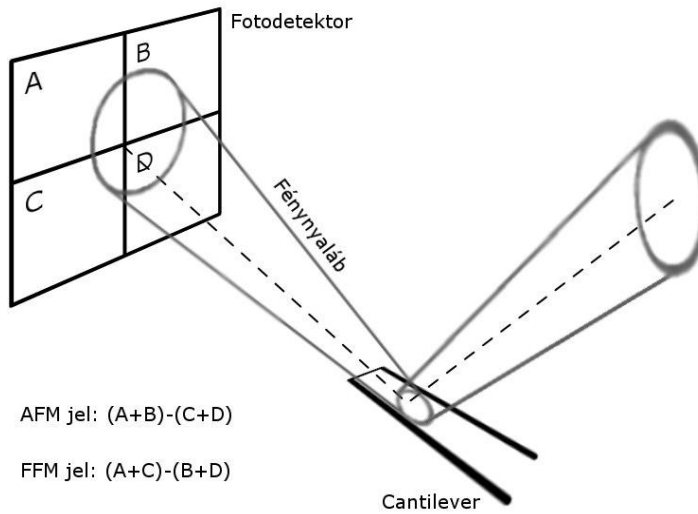
MOVEMENT OF AFM SAMPLE

- Inorganic crystal (e.g. lithium-niobate - LiNbO_3 , barium-titanate - BaTiO_3).
- The piezoelectric factor is typically $10^{-10} \dots 10^{-11}$ m/V



6

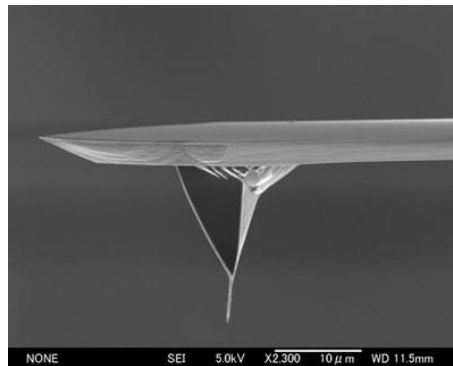
MEASUREMENT OF THE MOVEMENT OF THE CANTILEVER



2/10

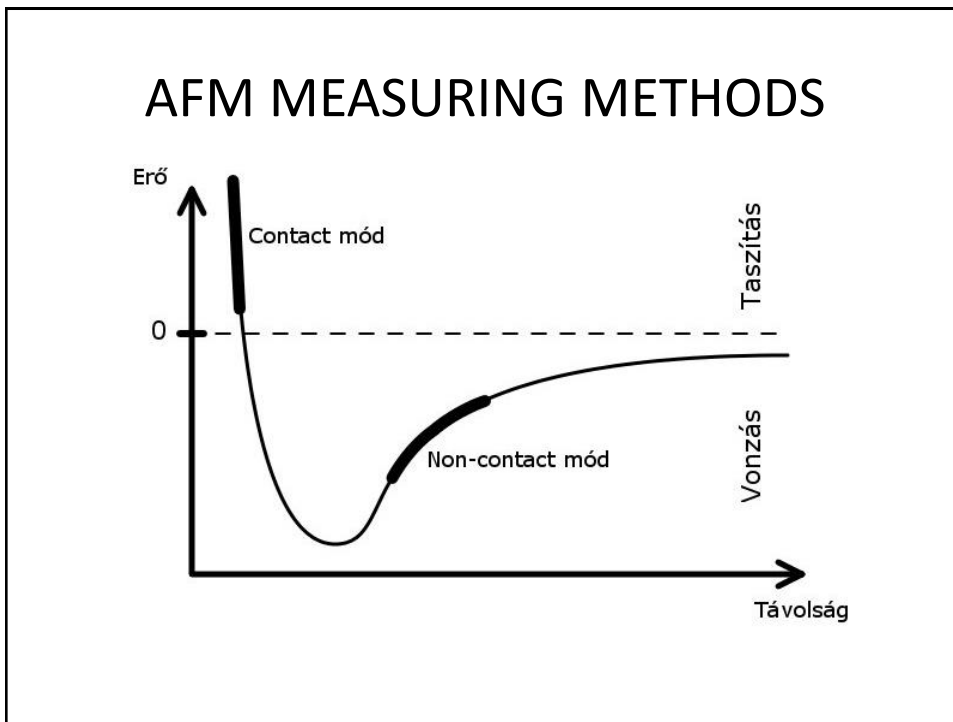
7

AFM NEEDLE



- Si mikromechanics
- Carbon nanotube
- SPM: ending in 1 atom
- AFM: 5-20 nm radius

8



9

AFM methods

- 3 basic modes:
 - contact,
 - „tapping”,
 - Non-contact.
- Main properties of the cantilever:
 - resonance-frequency,
 - elastic constant,
 - vibration amplitude.

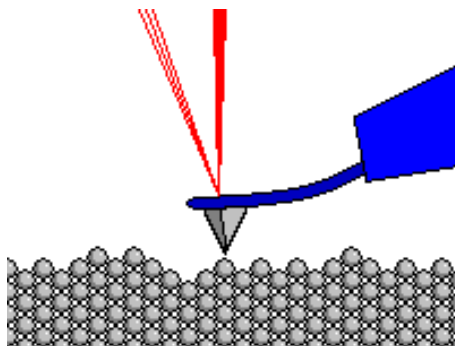
10

Contact mode

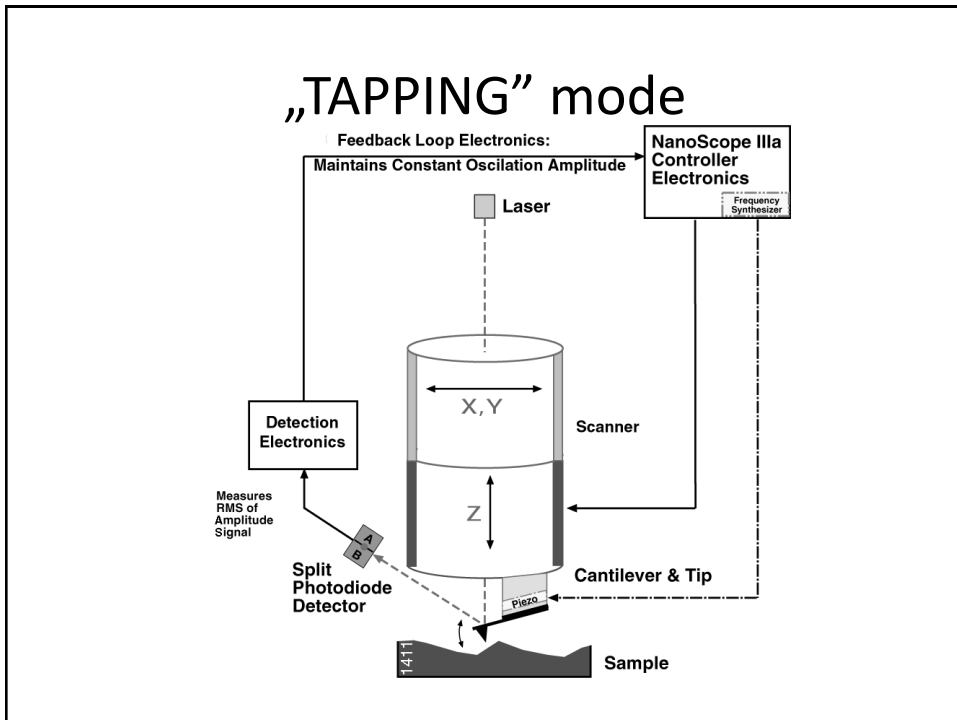
- Advantages:
 - quick,
 - atomic resolution,
 - measuring of non-uniform surfaces.
- Disadvantages:
 - effect of shear forces on the image,
 - sensitive samples can be hurt.

11

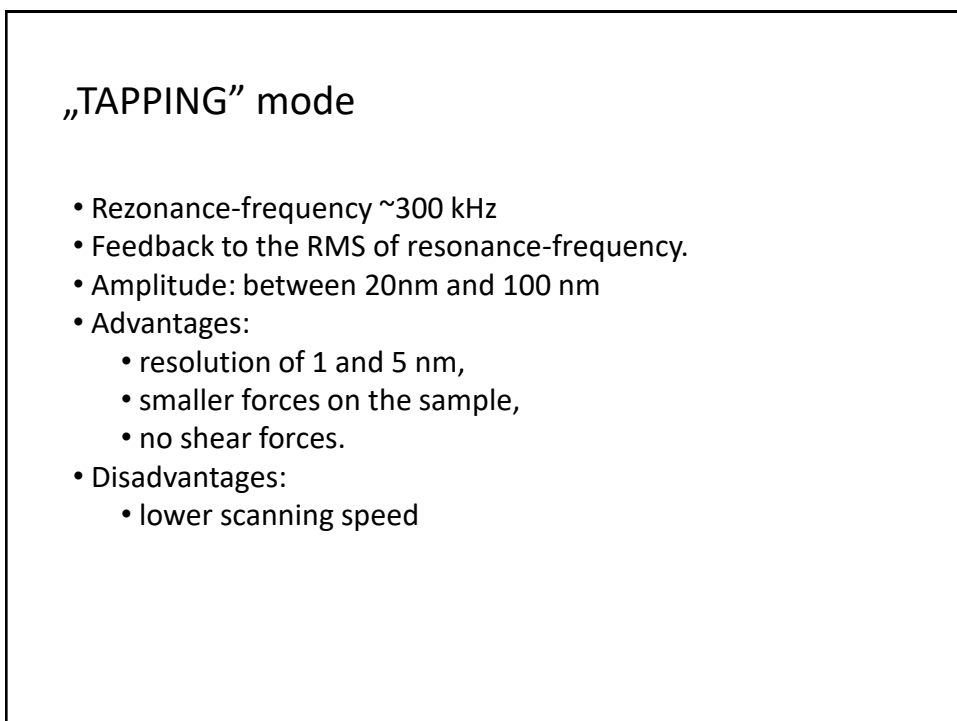
Contact mode



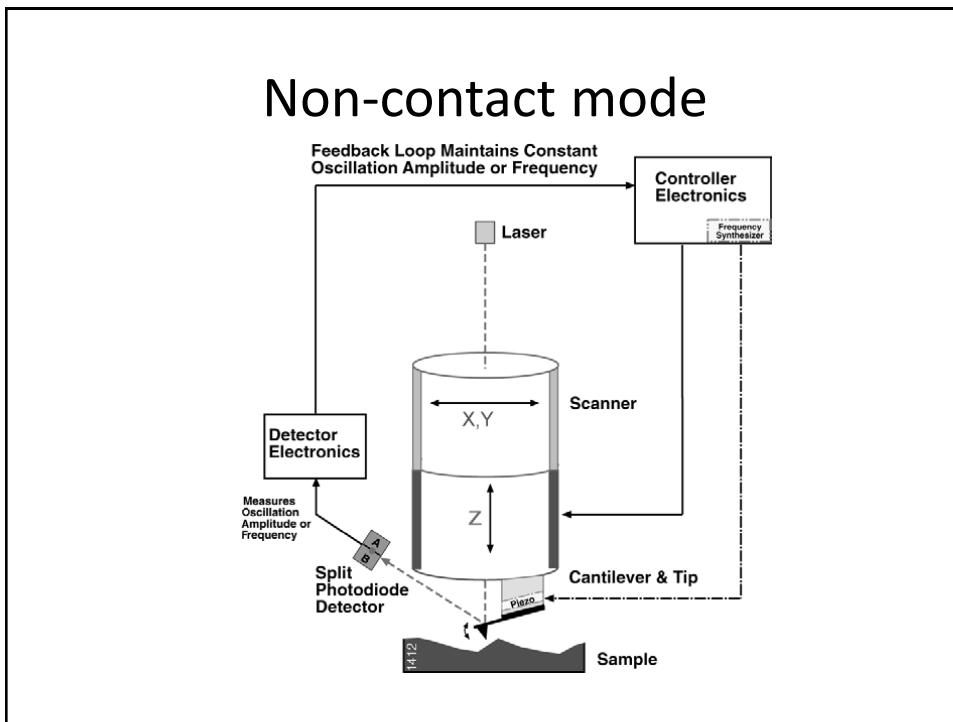
12



13



14



15

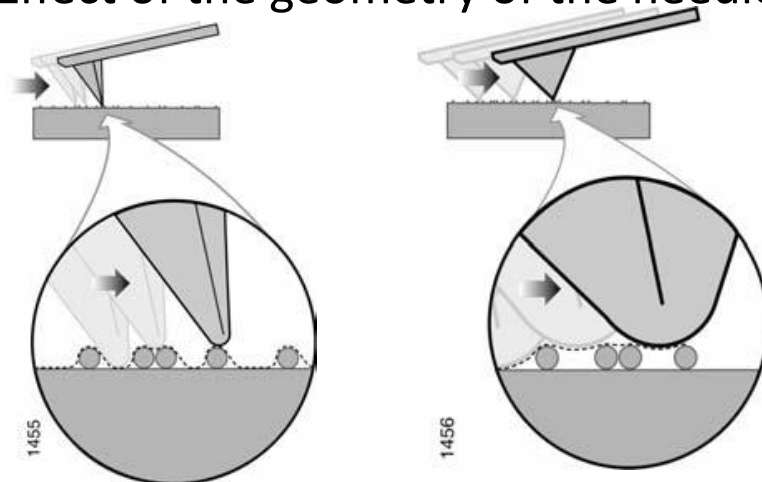
NEM-KONTAKT MÓD

- Amplitude: <10 nm
- Resonance-frequency decreases as we go closer to the surface – this is detected
- Advantages:
 - resolution of 1 and 5 nm,
 - lower forces on the sample,
 - no shear forces.
- Disadvantages:
 - much lower scanning speed (to avoid the needle to be „sticked”)
 - lower resolution

16

Image formation faults

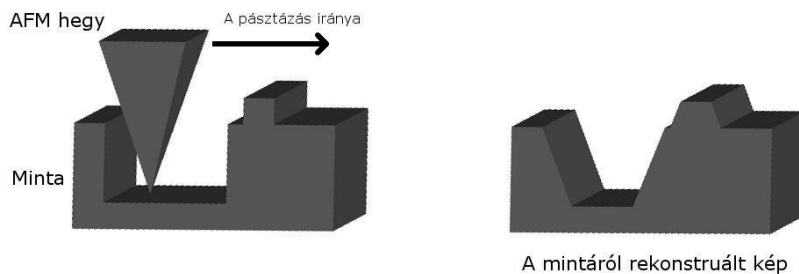
Effect of the geometry of the needle



17

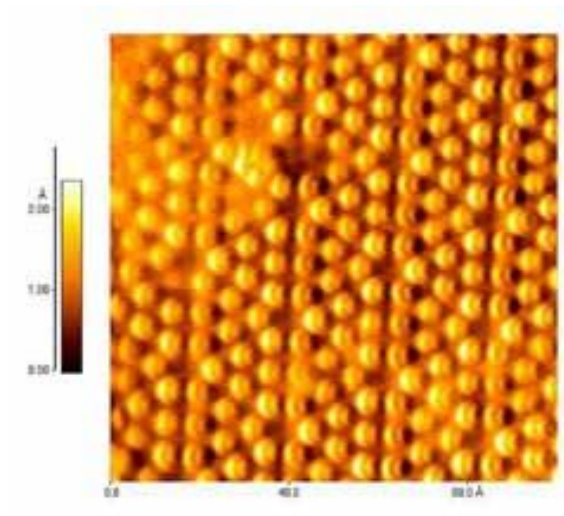
Image formation

Geometrical convolution



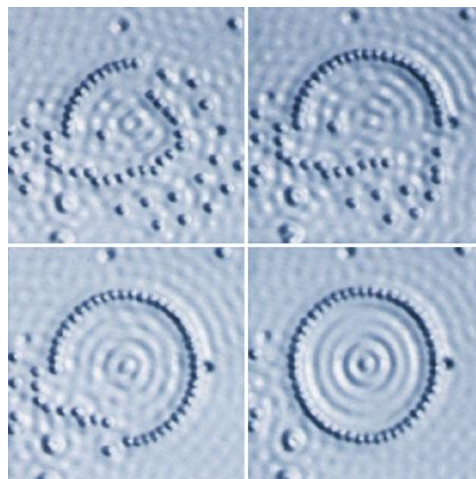
18

AFM



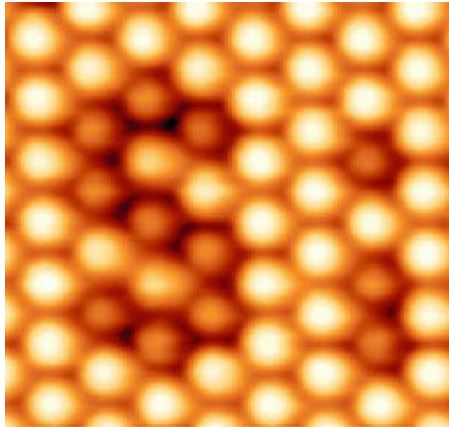
19

Moving atoms



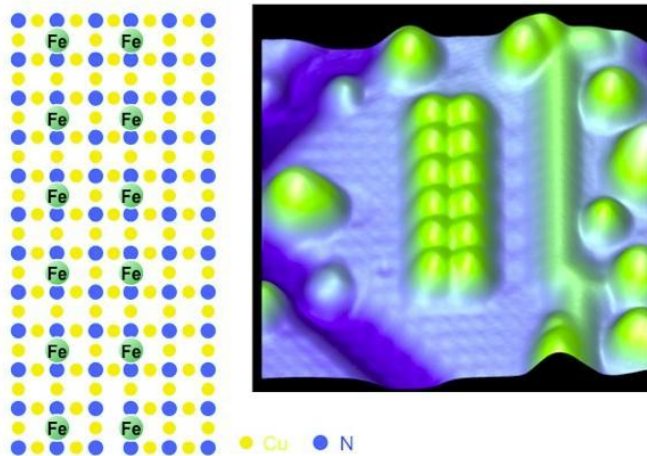
20

Smallest writing of the world



21

Data storage



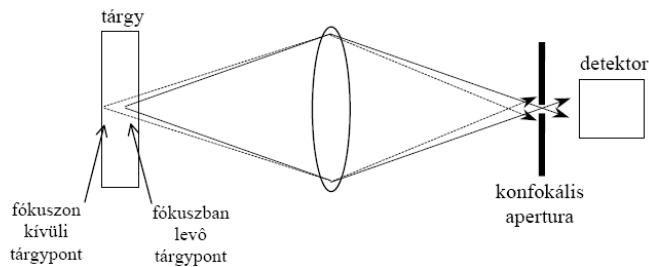
Operates at ~ 4 K... ☹

22

CLSM – CONFOCAL LASER SCANNING MICROSCOPE

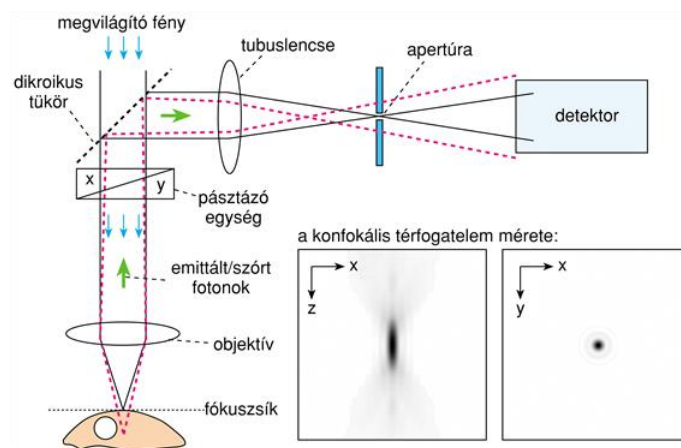
Advantages

- high depth-of-field
- simple sample preparation
- quantitative results



23

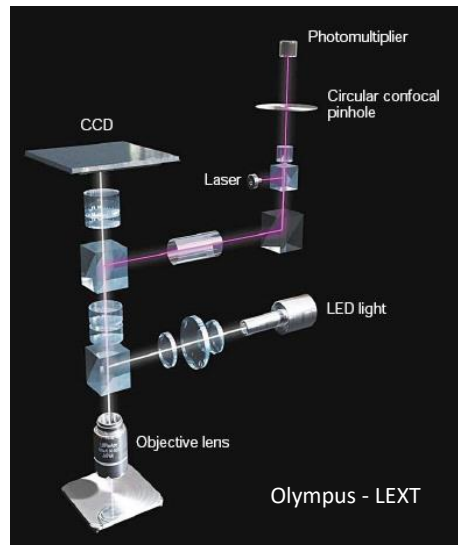
CLSM – CONFOCAL LASER SCANNING MICROSCOPE



24

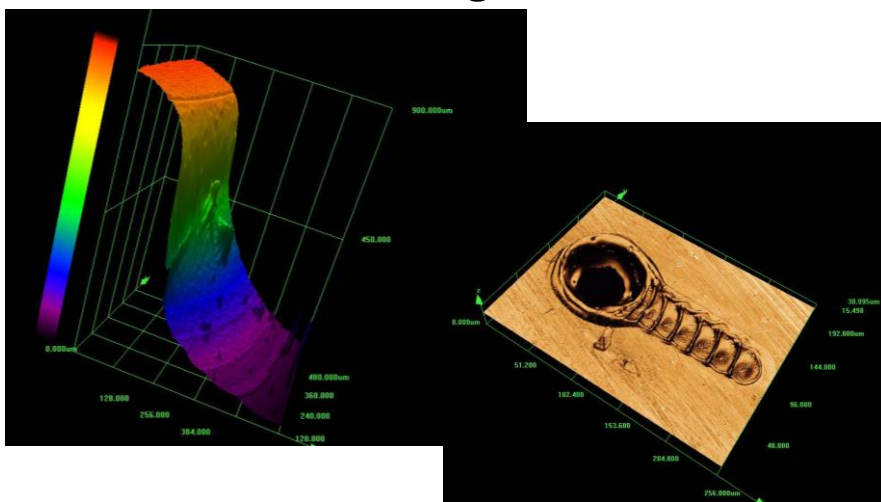
CLSM

- short wave (408 nm) laser illuminating– lateral resolution $\lambda/2$
- reflected light travels through an aperture – only one plane is sharp
- 3D image formation by moving the sample vertically



25

Solder meniscus – laser hole CLSM image



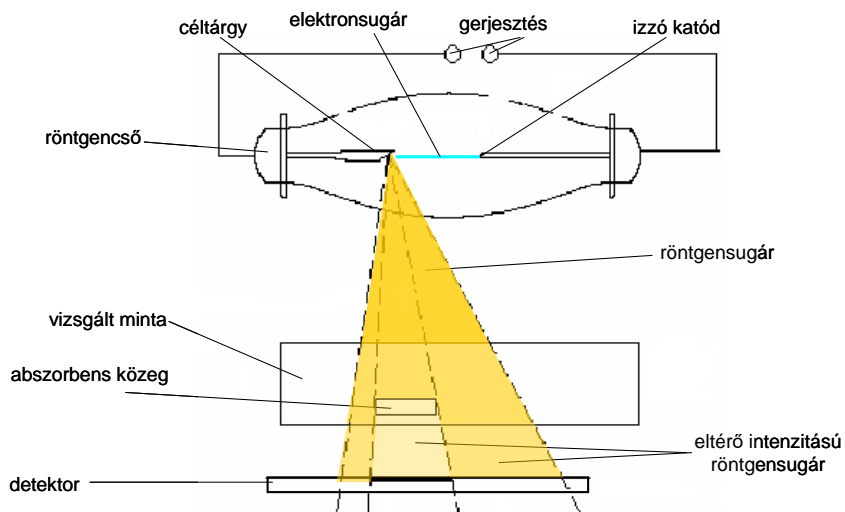
26

CLSM – main parameters

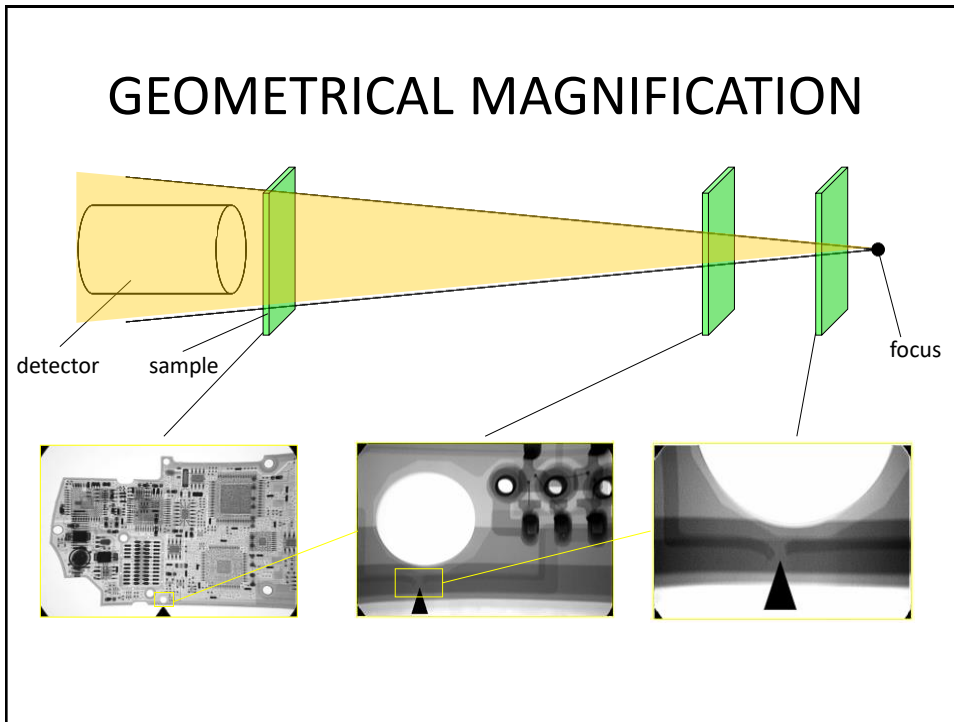
- x-y (lateral) resolution:
 - wavelength of light ($\sim \lambda/2$) <- laser,
 - numeric aperture ($\sim 1/NA$) <- objective lens diameter of the confocal aperture
- z resolution:
 - cca. 0,5-1,5 μm „thick” optical sections
 - numeric aperture ($\sim 1/NA$)
- speed
 - scanning speed vs. better signal/noise ratio

27

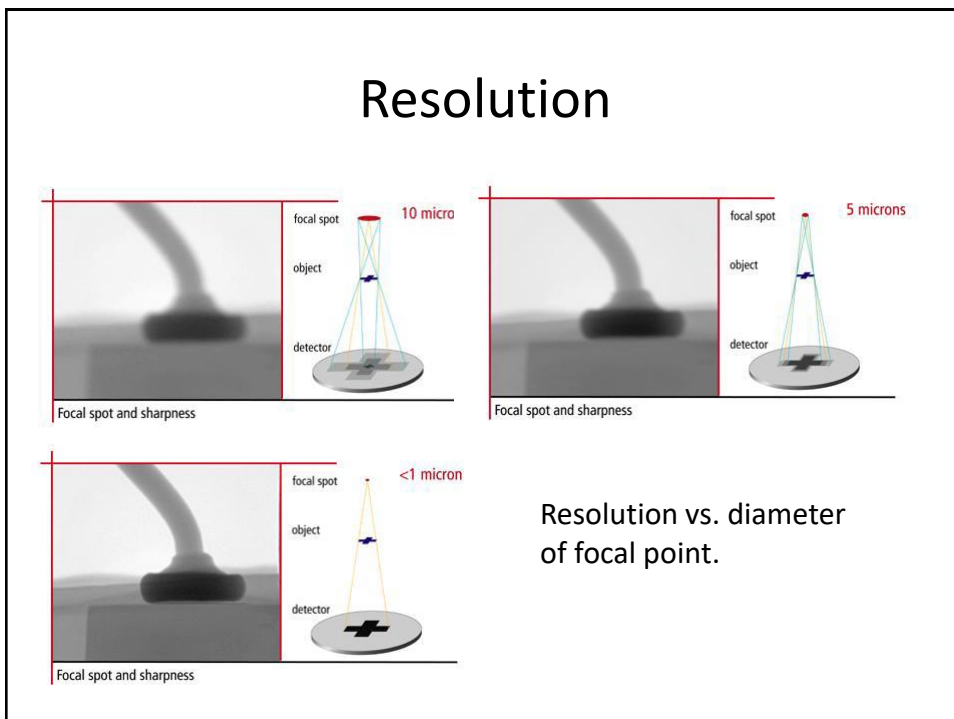
X-ray projection



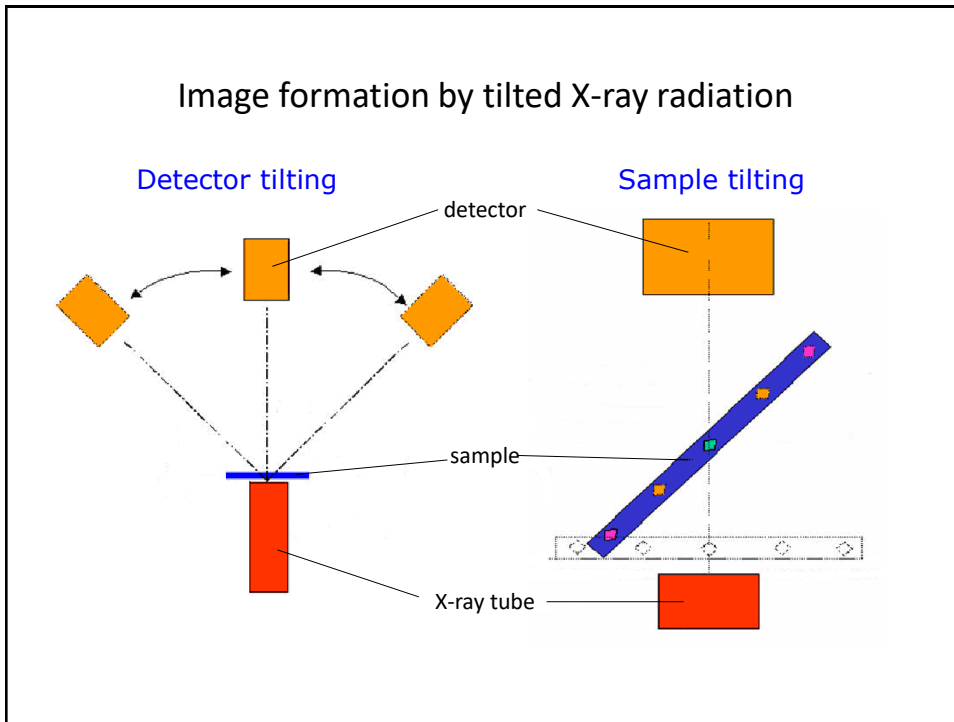
28



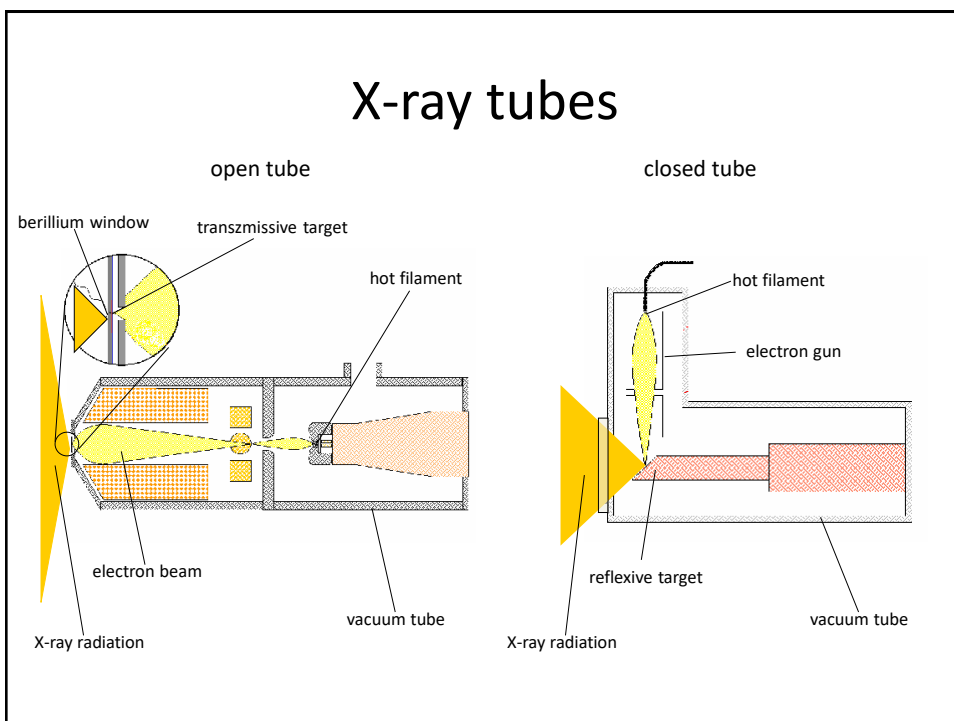
29



30

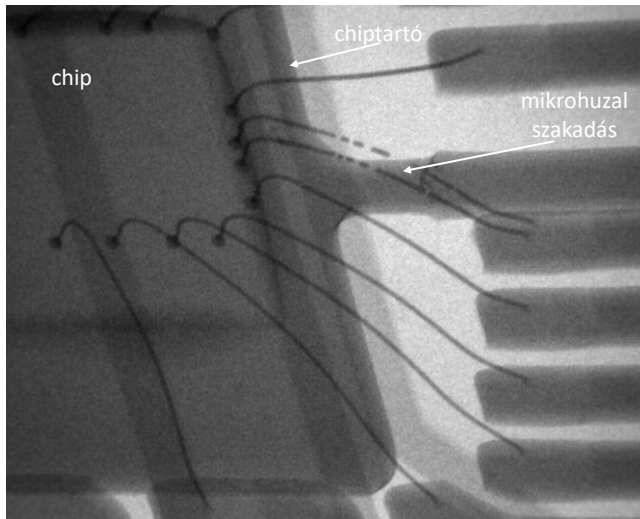


31

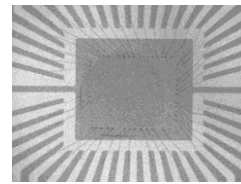


32

MIKROWIRES – FRACTURE

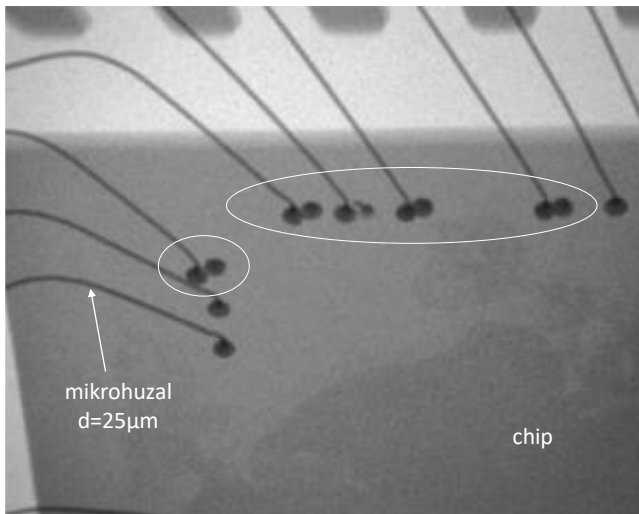


- too high current
- 2 mikrowires parallel, still molten
- tilted image shows the geometry of wires

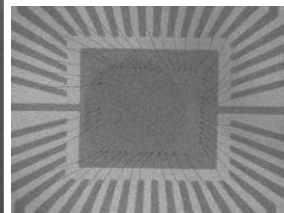


33

MIKROHWIRES - DELAMINATION



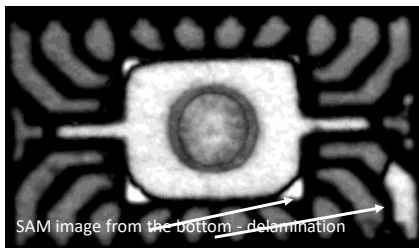
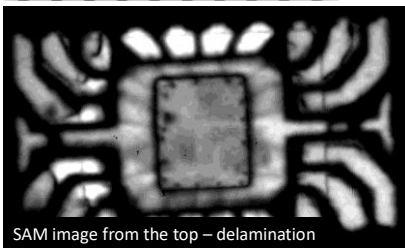
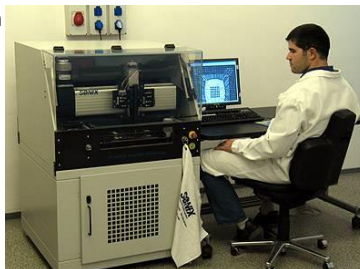
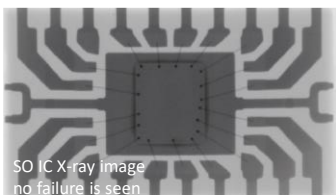
- tilted image shows delamination
- even chip glue is visible



34

SAM - SCANNING ACOUSTIC MICROSCOPY

- Cracks, inclusions, delaminations, which are invisible for X-ray.
- 15, 50, 75 and 110MHz transducers



35

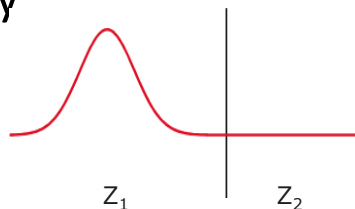
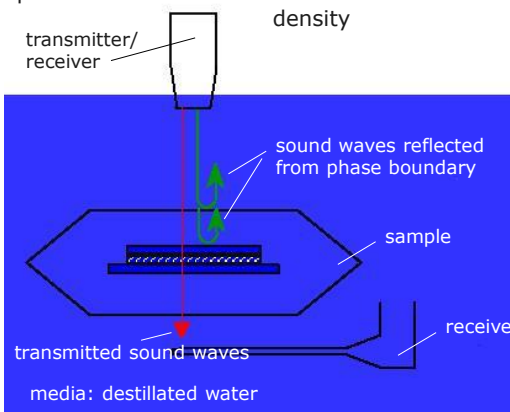
Principle of scanning acoustic microscopy

$$Z = \rho \cdot v$$

acoustic impedance

density

speed of the sound

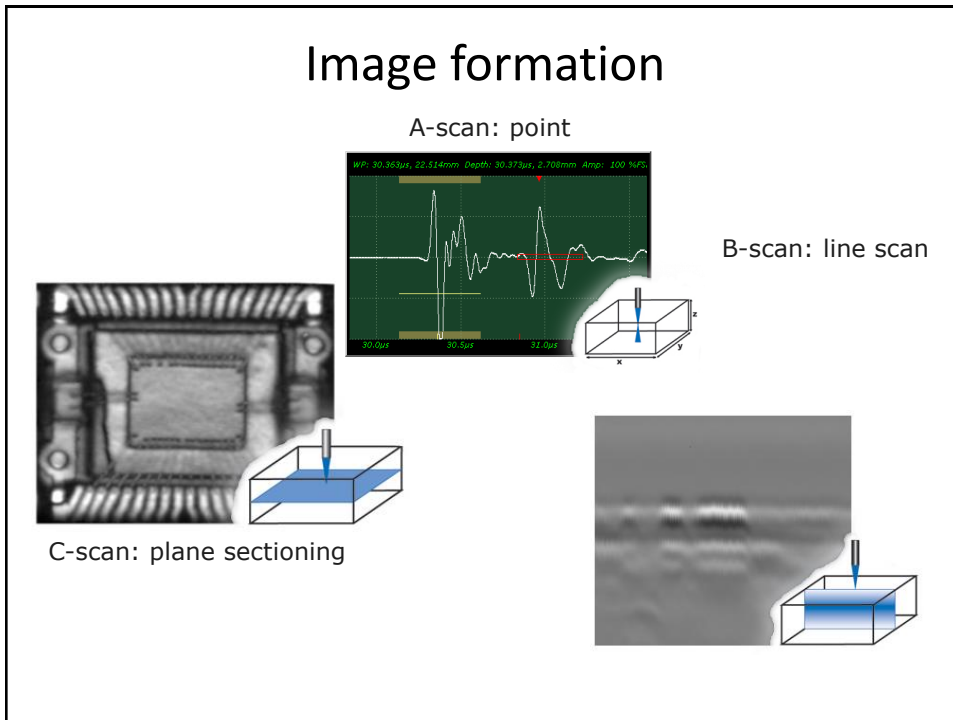


Phase boundary reflection:
different acoustic impedances

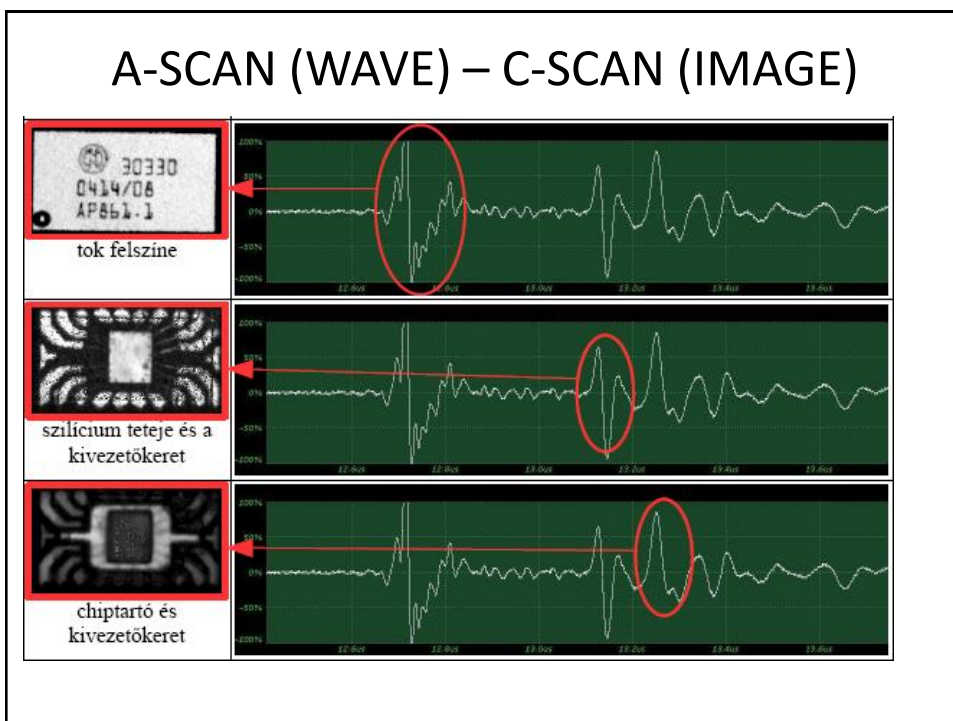
$$R = \frac{Z_2 - Z_1}{Z_2 + Z_1}$$

reflecting factor

36



37



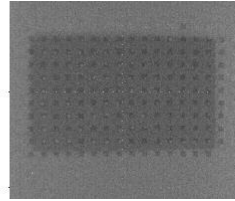
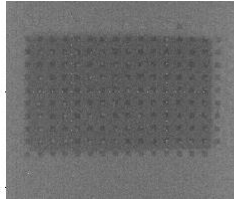
38

X-ray – acoustic imaging

Good sample,
small delamination

Bad sample,
almost full delamination

X-ray



SAM

